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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent of Paride Corbellini et al. ✓  
Patent No. 6,878,302  
Issued April 12, 2005  
Confirmation No. 8317  
For METHOD OF POLISHING WAFERS

March 15, 2006

**LETTER TO THE PATENT AND TRADEMARK OFFICE**

TO THE COMMISSIONER FOR PATENTS,

SIR:

The above-identified patent should read at the places indicated as follows:

On the Face of the Patent, (86):

"(2), (4) Date: Dec. 3, 2002" should read -- Dec. 5, 2002 --.

**REMARKS**

The patentee requests that the instant letter be placed in the file of Patent No. 6,878,302 for the purpose of calling attention to the incorrect date listed on the face of the patent. Applicant notified the Patent Office of the mistake on February 18, 2003 in the Response to Missing Parts. This letter is being filed to avoid burdening the Patent and Trademark Office with a request for a formal certificate of correction.

Respectfully submitted,

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